

10/511686

DT01 Rec'd PCT/PTC 13 OCT 2004

2388-845

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jan Harries HANSEN et al.
International Application No.: PCT/DK03/00222
International Filing Date: 2 April 2003
Priority Date Claimed: 15 April 2002
For: METHOD AND APPARATUS FOR MEASURING LIGHT
REFLECTIONS OF AN OBJECT

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450
Attn: DO/EO/US

S I R:

Prior to examination of the above captioned
application, kindly amend the application as follows:

EV507601516US